



566.41259X00

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): UCHIDA, et al.
Serial No. 10/069,404
Filed: May 26, 2002
For: POLISHING MEDIUM FOR CHEMICAL-MECHANICAL
POLISHING, AND POLISHING METHOD
Group: 1765
Examiner: L. Eronini

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

March 22, 2005

Sir:

In response to the Office Action mailed September 22, 2004, please amend the above-identified application as listed in the following, and as set forth on the following pages:

Amendments to the Claims; and

Remarks are included following the amendments.

03/24/2005 JADD01 00000062 10069404